

Applicants: HIMI et al.

Atty. Dkt.: 01-463

Serial No.: 10/656,326

Art Unit: 2811

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Examiner: NGUYEN

Title: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING

**SAME** 

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Randolph Building
401 Dulany St.
Alexandria, VA 22314

Date: 27 April 2006

## **AMENDMENT UNDER 37 CFR 1.111**

Sir:

In response to the office action mailed 30 December 2005, please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 7 of this paper.